

Atty. Docket No. PPW06-560DS

RECEIVED  
CENTRAL FAX CENTER  
OCT 31 2006IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Jae-Won HAN

: GROUP ART UNIT: 2812

APPLICATION NO: 10/751,172

FILED: DECEMBER 30, 2003

: EXAMINER: LEE, Kyoung

FOR: METHOD FOR MANUFACTURING  
SILICIDE AND SEMICONDUCTOR  
WITH THE SILICIDE

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 31, 2006.

By: Jennie Heaton  
Jennie HeatonAMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132  
AND 37 C.F.R. 1.111Mail Stop AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

Responsive to the Office Action dated May 31, 2006, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendments and remarks.